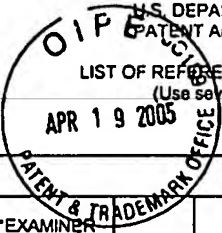


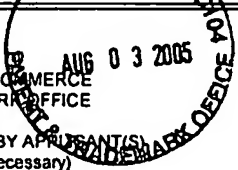
FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)			ATTY DOCKET NO. <b>03500.017972</b>		APPLICATION NO. <b>10/807,103</b>		
			APPLICANT <b>KOICHI MATSUDA ET AL.</b>				
			FILING DATE <b>March 24, 2004</b>		GROUP <b>1709</b>		
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JS		5,021,100	06/04/91	Ishihara et al.	136	249	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
JS	JP	2001-308354	11/02/01	Japan			Abstract
JS	JP	2-237172	09/19/90	Japan			Abstract
JS	JP	63-77167	04/07/88	Japan			No
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
JS	<del>Yamamoto, Kenji, "Thin-film polycrystalline Silicon Solar Cell", Applied Physics, The Japanese Society of Applied Physics, May 2002, Vol. 74 No. 5, pp. 524-527.</del>						
EXAMINER				DATE CONSIDERED			
/Jackson Smith/				04/18/2007			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

Form #62

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FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. <b>03500.017972</b>		APPLICATION NO. <b>10/807,103</b>	
				APPLICANT <b>KOICHI MATSUDA ET AL.</b>			
				FILING DATE <b>March 24, 2004</b>		GROUP <b>1709</b>	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
JS		K. Yamamoto, "Thin-film Polycrystalline Silicon Solar Cell", Applied Physics, The Japan Society of Applied Physics, May, 2002, vol. 71, No. 5, pgs. 522-527 (English translation)					
JS		K. Yamamoto, "Thin-film Polycrystalline Silicon Solar Cell", Applied Physics, The Japan Society of Applied Physics, May, 2002, vol. 71, No. 5, pgs. 522-527 (with handwritten English translation of text shown in drawings)					
EXAMINER      /Jackson Smith/				DATE CONSIDERED      04/18/2007			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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	APPLICANT <b>KOICHI MATSUDA ET AL.</b>	
	FILING DATE <b>March 24, 2004</b>	GROUP <b>1709</b>

U.S. PATENT DOCUMENTS



*EXAMINER		DOCUMENT					FILING DATE
JS		6,180,870 B1	01/30/01	Sano et al.	136	258	
JS		4,612,411	09/16/86	Wieting et al.	136	265	
JS		6,426,547 B1	07/30/02	Greenberg et al.	257	656	

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
JS	CN	1175095A	03/04/98	China			Abstract U.S. 6,180,870 B1

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
EXAMINER	/Jackson Smith/ DATE CONSIDERED <b>04/25/2007</b>